PATENT

Attorney Docket No. MTI-31532

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Weimer, Ronald A.

Serial No.:

09/941,827

Filing Date:

August 29, 2001

For:

Method of Improved High K Dielectric-Polysilicon Interface for CMOS

Devices

Examiner:

PHAM, Thanhha S.

Group Art Unit:

2813

Confirmation No.:

7551

CERTIFICATION OF SUBMISSION

I hereby certify that, on the date shown below, this correspondence is being transmitted via the Patent Electronic Filing System (EFS) addressed to Examiner PHAM at the U.S. Patent and Trademark Office.

Date: September 12 2006

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Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE (37 CFR § 1.312)

Sir:

In response to the Notice of Allowance mailed August 3, 2006, Applicant requests the following amendment be made to the above-identified application.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 29 of this paper.